

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: )  
Satoshi MURAKAMI et al )  
Serial No.: 09/516,082 )  
Filed: March 1, 2000 )  
Art Unit: 2815 )  
Examiner: Eugene Lee )  
Confirmation No: 3545 )  
For: SEMICONDUCTOR DEVICE COMPRISING A )  
THIN FILM TRANSISTOR COMPRISING A )  
SEMICONDUCTOR THIN FILM AND METHOD OF )  
MANUFACTURING THE SAME )

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, Applicant hereby calls the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. Pursuant to 37 CFR §1.98(a)(2)(i) copies of cited US patent and US patent application publications are not submitted herewith.

**REQUEST FOR CONSIDERATION OF PREVIOUSLY CITED REFERENCE**

US patent no. 6,346,718 was submitted in an IDS in this case on October 17, 2003 (a copy of the IDS and returned post card are attached hereto). It appears that this IDS has not yet been

considered by the Examiner. Therefore, Applicants respectfully request that US patent 6,346,718 be considered and made of record in this case.

**CORRECTION OF PREVIOUSLY SUBMITTED 1449 FORM**

On June 30, 2004, Applicants filed an information disclosure statement and PTO form 1449 in which there may be a error in the reference number.

Specifically, under "FOREIGN PATENT DOCUMENTS" on form 1449, Applicants believe that the correct Japanese reference number should be "**JP 8-328000;**" (not "JP 8328000/1996").

Accordingly, Applicants are submitting a new 1449 form with this correction. Applicants are also adding new reference US 7,037,737, on the 1449 form.

No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a

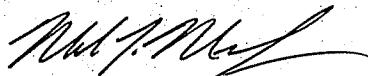
particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

**FEE**

As an RCE is being submitted herewith, no fee is believed due for this IDS. However, if any such fee is required, please charge our Deposit Account No. 50/1039.

Respectfully submitted,



Mark J. Murphy  
Registration No: 34,225

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Satoshi MURAKAMI et al

Serial No.: 09/516,082

Filed: March 1, 2000

Art Unit: 2815

Examiner: E. Lee

For: SEMICONDUCTOR DEVICE COMPRISING A  
THIN FILM TRANSISTOR COMPRISING A  
SEMICONDUCTOR THIN FILM AND METHOD  
OF MANUFACTURING THE SAME

)  
) I hereby certify that this correspondence  
) is being deposited with the United States  
) Postal Service as first class mail in an  
) envelope addressed to:  
) Commissioner for Patents, P.O. Box 1450,  
) Alexandria, VA 22313-1450, on October 17,  
2003

Cristie m. noll

) Date: October 17, 2003

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992, 1135 OG 23-24, Applicant hereby calls the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. Copies of the references are enclosed herewith for the Examiner's consideration.

No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

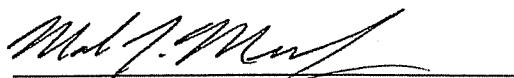
The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not

possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

A first office action, notice of allowance or issue fee notification has been received in this case, so a check in the amount of \$180.00 is enclosed. If any additional fee is required, please charge Deposit Account No. 50/1039.

Respectfully submitted,



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LIST OF PUBLICATIONS CITED BY APPLICANT	<u>Attorney Docket No.</u> SEL 163	<u>Serial No.</u> 09/516,082
	<u>Applicant</u> Satoshi MURAKAMI et al	
	<u>Filing Date</u> March 1, 2000	<u>Group</u> 2815

U. S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	6,346,718 B1	02/12/02	Yamanaka et al	257	79	10/06/99

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE

OTHER PUBLICATIONS  
(Including Author, Title, Date, Pertinent Pages)

EXAMINER:	DATE CONSIDERED:
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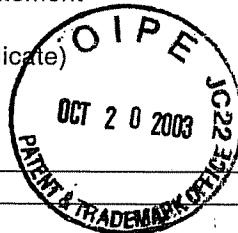
\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.

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MANO, CULLEN, & HARRIS  
ATTORNEYS AT LAW

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OFFICIAL MAILROOM STAMP AFFIXED  
HERETO, ACKNOWLEDGES RECEIPT OF:

ENCLOSURES:

( ) Application \_\_\_\_\_  
( ) Specification \_\_\_\_ pages  
( ) Claims \_\_\_\_ pages  
( ) Abstract \_\_\_\_ page(s)  
( ) Drawing Sheets no. \_\_\_\_ (F) \_\_\_\_ (INF) \_\_\_\_  
( ) Transmittal Letter  
(X) Check \$ 180.00 No: 14830  
( ) Declaration/Oath  
( ) Assignment and Cover Sheet  
(X) Information Disclosure Statement & References  
( ) Response/Amendment  
( ) Extension of Time (In Duplicate)  
( ) Small Entity Status  
( ) Copy of Priority Document  
( ) \_\_\_\_\_  
( ) \_\_\_\_\_



RE: APPLICATION ATTY/SEC: MJM/cn  
File no: 0553-0163

Applicant: Satoshi MURAKAMI et al

S.N.: 09/516,082 Filing Date: March 1, 2000

Filed: Semiconductor Device Comprising A  
Thin Film Transistor Comprising A Semi-  
Conductor Thin Film and Method of...

Due date: \_\_\_\_\_ Date Sent: 10/17/2003

SEL  
0553-0163  
EDM/mjm

SEARCHED	INDEXED
SERIALIZED	FILED
OCT 20 2003	
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